



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#7/Response

WDA-03-03

In re application of : Confirmation No. 6291  
Kenji KAMIMURA et al. : Docket No. 2001-0076A  
Serial No. 09/787,121 ✓ : Group Art Unit 3723  
Filed March 14, 2001 : Examiner Rose, Robert A.  
POLISHING APPARATUS

TECHNOLOGY CENTER R3700

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RESPONSE TO RESTRICTION REQUIREMENT

Assistant Commissioner for Patents,  
Washington, D.C.

THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
FEES FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975

Sir:

This is in response to the Restriction Requirement of December 31, 2002.

Applicants, by their undersigned representative, hereby elect the invention of Group I, which is drawn to an apparatus for polishing, and is represented by claims 1-3 and 7-19.

This election is made without traverse.

Having made the required election, a full examination on the merits of the elected invention is hereby requested.

Respectfully submitted,

Kenji KAMIMURA et al.

By: \_\_\_\_\_

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